PRELIMIARY DESIGN OF HEPS STORAGE RING VACUUM CHAMBERS AND COMPONENTS

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- 2. Vacuum chamber design
- 3. Special Hardware components Development
- 4. Conclusions



Introduction

Goals and the target performance of LS (Light Source) storage rings:

Constant delivery of a high quality, intense and stable photon beam to a large number of beamlines

High quality and intense photon beams: Often characterized in terms of

Brilliance =
$$\frac{Photons}{Second \cdot mrad^2 \cdot mm^2 \cdot 0.1\%BW} \propto \frac{I}{\varepsilon_x \varepsilon_y}$$

I : Beam current, ε_{ν} : Transverse emittance

Presently a big global wave for 3GLS → DLSR (Diffraction Limited Storage Rings or 4GLS)

Lowering of transverse beam emittance

Optimal ring structure from DBA, TBA lattice -> MBA lattice

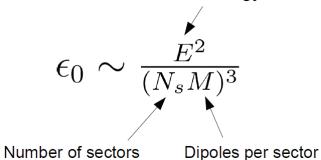
Ring-Based LS Future Trends

 A global wave today to construct (or reconstruct) ring-based LSs having the horizontal emittance ε_H by **tens of** factors below the "nm·rad" range

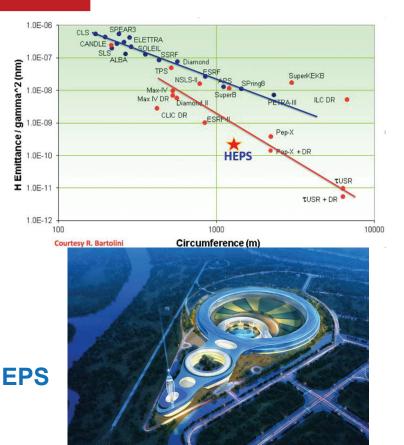
Basic principle used:

$$\left(\varepsilon_{\scriptscriptstyle H}\right)_{\scriptscriptstyle Minimum}^{\scriptscriptstyle Theoretical} \propto E^2 \cdot \theta^3$$

E: Beam energy, θ : Bending angle Beam energy



HEPS



Challenges on vacuum systems for Low Emittance/DLSRs

Main Purpose of DLSRs_Vacuum System Design:

Have low dynamic pressure which gives good beam lifetime, and to handle the power deposited by SR.

- High gradient quadruple → Small magnet bore aperture
 Vacuum Chamber designs compatible with magnet poles, photon extraction and beam stay clear conditions(space limitation)
- Handle the power deposited by SR →
 Integration of pumping ports, photon absorbers, collimators and crotches(high SR power)
- Small magnet bore aperture → Low profile vacuum chamber(Lumped pumping would not be as efficient in reducing the pressure)
 Detailed evaluation of vacuum profiles along the ring(conductance limitation)
- → NEG coating must be a very helpful method for DLSRs to provide distributed pumping
- Some specific hardware development in future DLSRs "Zero-impedance" flange, RF_shield Bellow, BPM etc...
- In-situ baking materials development
 thin Polyimide foil heater + Al coating polyimide foil



Vacuum System Design Options for 4th LS

Design Option	Impact on other systems	Risk	Cost for chambers, photon absorbers, distributed pumping
All NEG-coated copper chambers (MAX-IV, Sirius)	In-tunnel magnet disassembly or larger bore size could be required for installation and re-activation.	Medium	\$17.5k/m
All antechambers and discretely located absorbers	Lattice and magnet geometry (more space between magnets and magnet coils).	Very Low	\$10.6k/m
Hybrid	In-tunnel magnet disassembly may be required for reactivation.	Low	\$12.8k/m

HEPS Storage Ring Parameters

Beam Energy (GeV)	6
Current (mA)	200
Storage Ring (m)	1360.4
Booster (m)	453.5
Emittance (nm·rad)	0.06
Lattice	7BA
Straight Section Length (m)	6
Cell Number	48



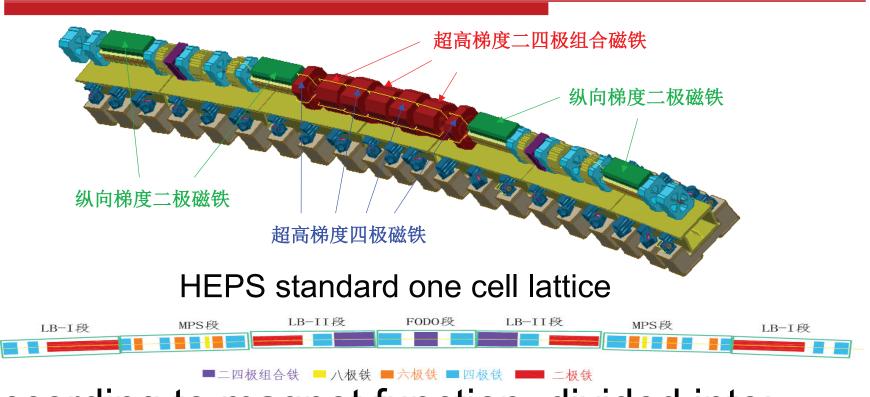


Compare with other LS

Table 1: New Ring-Based LS's Parameters

Facility	<u>C</u> (m).	E(GeV)/I(A) Ex(pm.rad)	Mag. Bore(mm)	Chamber Material	Baking Method
MAX-IV	528	3/0.5	25	OFS Cu	Ex-situ
(Sweden)	(20cell-7BA)	330		(100% NEG Coating)	
SIRIUS (Brazil)	518.4	3/0.5	28	OFS Cu	In-situ
	(20cell-5BA)	250		(100% NEG Coating)	
EBS (France)	844	6/0.2	26	SST/Al	In-situ
	(32cell-7BA)	135		(Partial NEG Coating)	
SPring-8_U	1436	6/0.1	26	SST	Ex-situ
(Japan)	(48cell-5BA	140		(No NEG Coating)	
APS_U (USA)	1100	6/0.2	26	OFS Cu/Al	Ex-situ
	(40cell-7BA)	60		(Partial NEG Coating)	

One Cell Layout of HEPS



According to magnet function, divided into: Q-doublet, L-bend, Multiplet, and FODO sections.

Vacuum Chamber @ Fast Corrector

Fast corrector between two Quads

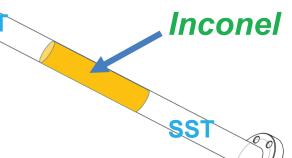


316LN SST: $7.4x10^{(-7)}Ωm$

Inconel: $1.28X10^{-6}$ Ω m

~40% Re. increase

prototype



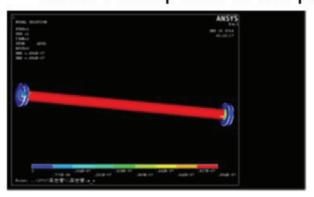


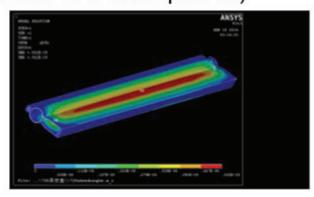
results:

- 1, tolerance meet specification;
- 2 leak rate<1E-10mbar.L/s:
- 3 after welding magnetic permeability<1.01.

Multiplet Chamber

(Loading is uniformly distributed and amounts 0.1N/mm², which corresponds to the pressure of 1 atmosphere.)



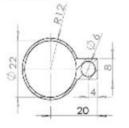


(Multiplet Vacuum Chambers)

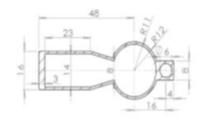
and

(X-ray Extraction Chambers)





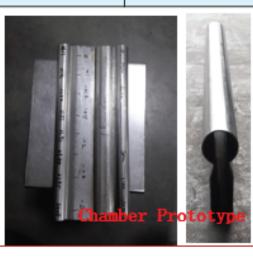




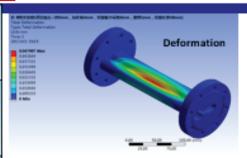
Chamber material: 316LN SST

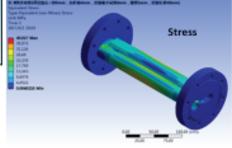
X-ray Extraction Chamber (L=255mm)

type	Cross-section	Max. Defor. (mm)	Max. Stress (MPa)
	1mm equal thickness	0. 215	146. 99
	Non-uniform thickness	0.0514	44. 282







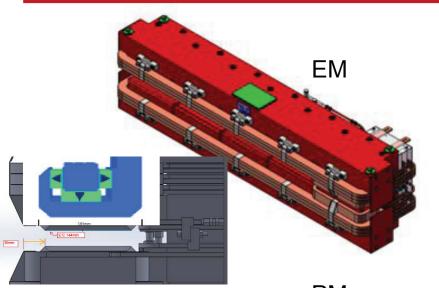


Results:

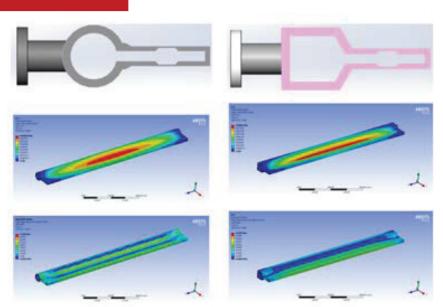
- 1, 1st prototype(316L), the permeability>1.04, max. deformation 0.25mm (Spec. 0.1mm) ;
- will measure again after welding flange, annealing, reshaping:
- 3, will modify tooling and then made from 316LN.



LGD Chamber (EM&PM)







Def. mm	Str. MPa	
0. 055	17. 81	
0. 086	44. 92	
•	0. 055	



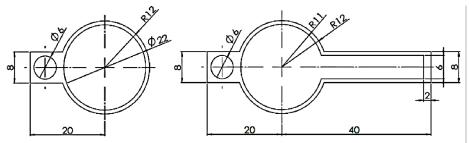
FODO Section Chamber

- Copper chambers with water-cooling channels on outboard side. High power synchrotron radiation hits the chambers, distributed photon absorber may needed.
- Upstream chamber is same as Multiplet chamber. Downstream chamber may include photon extraction slot for BM beamline.
- NEG coating needed in the center part.



OFS Copper (C10700) vacuum tube

Cross section:



Difficulties:

- Spend long time to find right material
- Thin wall, small cross section, hard to machine

vendor@Shanghai technique solution:

Cir. and Rec. tube extruded together, and then brazing the cooling water channel



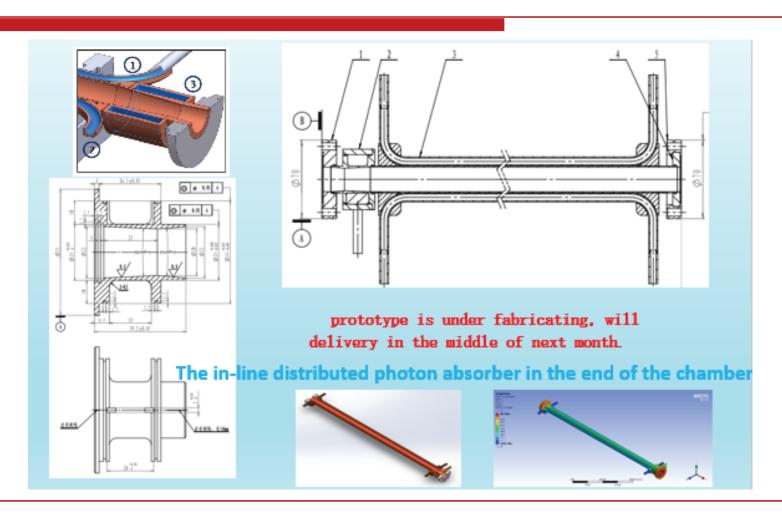


Gas brazing test, filler is not fully fill up





In-line GlidCop absorber copper tube

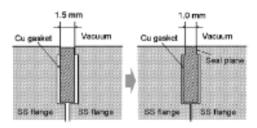




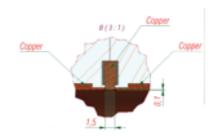


Matsumoto-Ohtsuka (MO)

- -type flange
- No gap
- No step
- · Smooth inner surface
- Beam only see copper

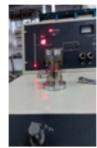


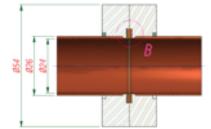
Pto. 2. Conceptual principle of the MO-type flange. The vacuum is sealed by a plane (seal plane) at just the inner surface.



MO type bolts

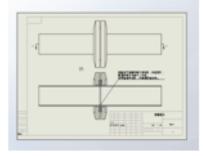






MO type clamps









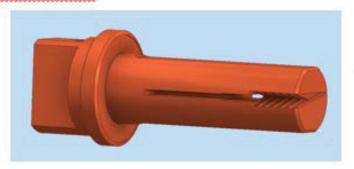
Photon Absorber

GlidCop



Brazing GlidCop_AL_15 to stainless steel (SST) by using filler 50Au/50Cu in a vacuum furnace

CrZrCu



100% machined, no brazing, no welding



Handle higher SR Power

Material Selection "Glidcop AL-15 Vs Copper Chromium Zirconium (C18150)"

Material Properties

Thermal Conductivity (RT):

Glidcop Al25, Al15: 344 - 365 W/(m.K)

Cu-Cr-Zr: 314 - 335 W/(m.K)

O Elastic Modulus:

Glidcop Al15, Al25: 130 GPa

Cu-Cr-Zr: 123 GPa

○ 0.2 % Yield Strength, (RT, Cold Worked):

Glidcop Al15, Al25: 470 - 580 MPa

Cu-Cr-Zr: 350 - 550 Mpa

Coefficient of Thermal Expansion:

Glidcop Al15, Al25: 16.6 μm/K

Cu-Cr-Zr: 17.0 μm/K

- Cu-Cr-Zr (C18150) is 1/4th the price of Glidcop AL-15.
- Cu-Cr-Zr is readily available in different forms and sizes from many suppliers.
- Cu-Cr-Zr loses its strength rapidly if exposed to sustained temperatures > 500°C
- Glidcop is the choice if brazing is required.

Ref: Li M. and Zinkle S. J. (2012) Physical and Mechanical Properties of Copper and Copper alloys, Comprehensive Nuclear Materials, Vol. 4, pp 667-690



GlidCop absorber prototype



Brazing GlidCop_AL_15 to stainless steel (SST) by using filler 50Au/50Cu in a vacuum furnace

Sample Testing

Shear strength A 30MPa Shear strength B 184MPa

SEM analysis A have no capillary action

SEM analysis B have capillary action but several voids

Vacuum leakage testing V

Vendor still work on the new brazing procedure



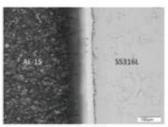
Shear strength A



Shear strength B

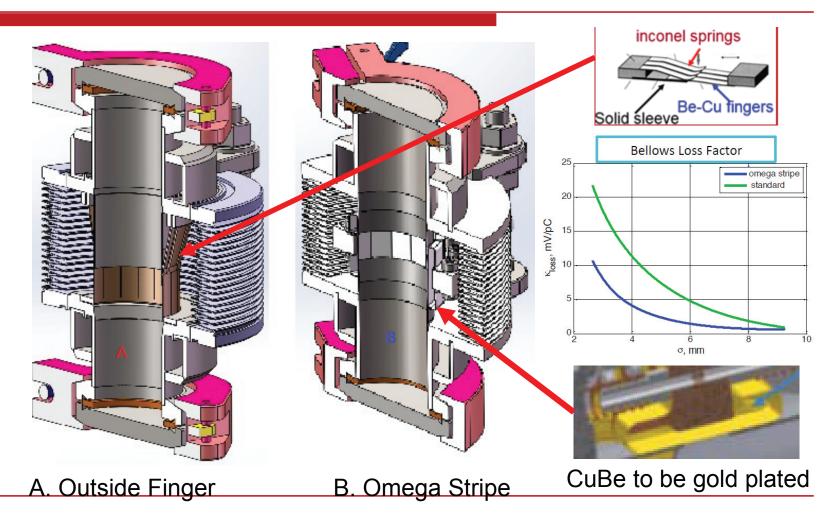


SEM analysis A



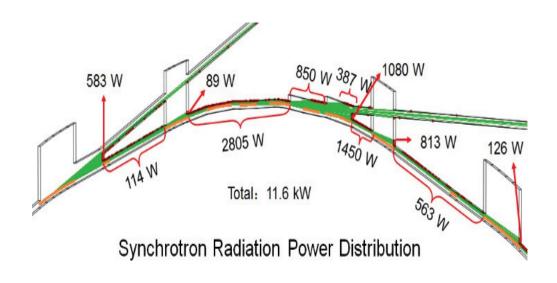
SEM analysis B.

RF Shielded Bellow





SynRad Ray Trace Analysis



The higher power radiation generated primarily in central section and at outer ends (near ID straight section). FODO chambers receive more than half of the total power. Straight multiplet chambers receive very little power.

These results provide much help to chamber and absorber design

Need more detail simulation and then optimize the design



Summary

- The HEPS vacuum system scope and interfaces with other systems are well defined.
- The vacuum system conceptual design for HEPS has been developed which meets the stated requirements. To cope with high synchrotron radiation, high photon flux, intense HOM excitation, strong collective effect, and so on.
- Major design alternatives have been considered.
- Risks have been accounted for.
- Vacuum hardware components prototype are under constructed.
- More R&D and analysis are necessary for mitigating the risks.

We have experienced various problems during the operation 3rd generation LSs, and learned lots of things. These experiences should be some of help for the future design of next-generation LSs.

Thank you for your attention

Vacuum Chamber Material

- 1. Elimination of aluminum-SS transition space.

 Spring-8 experience
- 2. High mechanical strength resulting in a reduced chamber thickness.
- 3. Suppression of the electron beam vibration originating from vibrations of the chamber.
- 4. Low outgassing rate resulting in an increase in intervals between the NEG reactivation.